

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: David S. Zuck and Kurtis R. Macura  
Assignee: Quantum Global Technologies, LLC  
Title: "Steam Cleaning System and Method for Semiconductor Process Equipment"  
Serial No.: Unknown Filed: September 16, 2003  
Examiner: Unknown Tel: Unknown  
Docket No.: QC-001-1C Art Unit: Unknown

Mail Stop Patent Application  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

September 16, 2003

**INFORMATION DISCLOSURE STATEMENT**

Sir:

Pursuant to 37 C.F.R. §1.56, §1.97 and §1.98, Applicants bring the 8 documents listed on the enclosed form PTO-1449 to the Examiner's attention in the above-captioned application. Citation of the listed documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant application;
2. a representation that a search has been made; or
3. an admission that the information cited is, or is considered to be, material to patentability as defined in §1.56(b).

I hereby certify that this correspondence is being deposited with the United States Postal Service as "Express Mail Post Office to Addressee" service under 37 CFR §1.10 on the date indicated below and is addressed to: Mail Stop Patent Application, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

09/16/03  
Date

  
Laurie Moreno

Respectfully submitted,



Arthur J. Behiel  
Attorney for Applicants  
Reg. No. 39,603

U.S. Department of Commerce, Patent and Trademark Office						Serial No.:	
						Filing Date: 09/16/2003	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT						Inventors: David S. Zuck and Kurtis R. Macura	
(Use several sheets if necessary)						Group Art Unit: Unknown	
"Steam Cleaning System and Method for Semiconductor Process Equipment"						Examiner Name: Unknown	
						Attorney Docket No. QC-001-1C	
U.S. Patent Documents							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date, If Appropriate
	AA	4,083,946	04/1978	Schurr et al.	423	613	
	AB	5,172,728	12/1992	Tsukazaki, Hideo	137	637.2	
	AC	5,545,289	06/1996	Chen et al.	438	694	
	AD	6,146,469	11/2000	Toshima, Masato	134	37	
	AE	6,460,552	10/2002	Lorimer, D'Arcy H.	134	148	
Foreign Patent Documents							
							Translation
		Document Number	Date	Country	Class	Subclass	Yes      No
	AF	JP 407273078A	10/1995	Japan			
	AG	EP0489179A1	06/1992	Europe			
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
	AH	CRC Handbook of Chemistry and Physics, A Ready-Reference Book of Chemical and Physical Data, cover sheet, 8-102 and 8-103. 1999-2000, 80 <sup>th</sup> edition. CRC Press (Boca Raton, London, New York, and Washington D.C.)					
	AI						
	AJ						
	AK						
Examiner				Date Considered			
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.</p>							